

**TRANSMITTAL**

Electronic Version v1.1

Stylesheet Version v1.1.0

**Title of  
Invention****THIN FILM TRANSISTOR ARRAY SUBSTRATE AND  
MANUFACTURING METHOD THEREOF**

Application Number :

Date :

First Named Applicant: Mr. Han-Tung Hsu

Confirmation Number:

Attorney Docket Number: 13130-US-PA

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**Submitted By:****Elec. Sign.****Sign. Capacity**

Dr. Belinda Lee

/Belinda Lee/

Agent

Registered Number: 46863

| Documents being submitted: | Files   |
|----------------------------|---|
| us-assignment              | 13130-usassn.xml<br>us-assignment.xsl<br>us-assignment.dtd<br>13130assignment1.tif<br>13130assignment2.tif  |
| us-request                 | 13130-usrequ.xml<br>us-request.dtd<br>us-request.xsl  |
| us-fee-sheet               | 13130-usfees.xml<br>us-fee-sheet.xsl<br>us-fee-sheet.dtd  |
| application-body           | 13130usf.xml<br>application-body.dtd<br>Image1.tif<br>Image10.tif<br>Image2.tif<br>Image3.tif<br>Image4.tif<br>Image5.tif<br>Image6.tif<br>Image7.tif<br>Image8.tif<br>Image9.tif<br>isoamsa.ent<br>isoamsb.ent<br>isoamsc.ent<br>isoamsn.ent<br>isoamso.ent<br>isoamsr.ent<br>isobox.ent<br>isocyr1.ent<br>isocyr2.ent<br>isodia.ent<br>isogr1.ent<br>isogr2.ent<br>isogr3.ent<br>isogr4.ent<br>isolat1.ent<br>isolat2.ent<br>isomfrk.ent<br>isomopf.ent<br>isomscr.ent<br>isonum.ent<br>isopub.ent<br>isotech.ent<br>mathml2.dtd<br>mathml2-qname-1.mod<br>mmlalias.ent<br>mmlextra.ent |

|   |                         |
|---|-------------------------|
|   | soextblx.dtd            |
|   | us-application-body.xml |
|   | wipo.ent                |
| application-body-pdf-wrap   | 13130usf-pdf-wrap.xml   |
| abstract-pdf  | 13130usf-abst.pdf       |
| claims-pdf  | 13130usf-clms.pdf       |
| description-pdf   | 13130usf-desc.pdf       |
| drawings-pdf  | 13130usf-draw.pdf       |
| us-declaration  | 13130declaration1.tif   |
| us-declaration  | 13130declaration2.tif   |
| <b>Comments</b>   |                         |
| <p>Please be kindly advised that the indicated fee of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fee in connection with this application to Deposit Account No. 50-2620(Order No.13130-US-PA). Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: Belinda@jicpgroup.com.tw; usa@jicpgroup.com.tw</p> |                         |